

EAST-10021203.wsp:11

Eis View Tools Window Help

Drafts Pending Active Filed Saved

US-AUTOMATIC FOCUSING DEVICE AND METHOD

Detail processor: OA

356/524.cds. and depth

[Print] [Search] [Clear]

[Blanks] [Highlight terms in index]

S1: (25) ("5,867,256") or ("4,988,189") or ("4,993,830") or ("4,935,613") or ("4,988,189")
S2: (5) Forward citation search 1
S3: (10) Backward citation search 1
S4: (4) Forward citation search 2
S5: (14) (depth with hole) same light same image same distance
S6: (66) 356/626.cds.
S7: (10) Backward citation search 2
S8: (19) Forward citation search 3
S9: (4) 356/626.cds. and (depth with hole)
S10: (11) Forward citation search 4
S11: (0) 356/240.1.cds. and (depth with hole)
S12: (9) 356/241.1.cds. and (depth with hole)
S13: (197) image and subtract and (depth with hole) and distance
S14: (5) \$13 and workpiece
S15: (15) Forward citation search 5
S16: (2) 356/626.cds. and (depth with cavity)
S17: (10) 356/626.cds. and (depth with well)
S18: (3) Backward citation search 3
S19: (0) 3256/4.03.cds.
S20: (58) 356/4.03.cds.
S21: (14) S20 and depth
S22: (3) Backward citation search 4
S23: (11) Backward citation search 5
S24: (3) Forward citation search 6
S25: (20) 356/524.cds. and depth and image

356/524.htm 356/524.pdf 356/524.html 356/524.xls

US-Nr.	Document-Ref.	Issue-Date	Pages	Title	Current-Ref.	Current-Xref	Classification-Class	Inventor	US	C	E	A	G	EP	GB	DE	IT
R	US 4767211 A	19880830	:18	Apparatus for and method of measuring boundary surface	356/624	356/446; 356/609	356/524	Munakata; Chusuke et al.	<input checked="" type="checkbox"/>	US							
	US 20030215725 A1	20031120	:20	Method for determining depth of focus	430/30	355/55; 355/77;	356/524	Watanabe; Akira	<input checked="" type="checkbox"/>	US							
	US 20030038950 A1	20030227	:9	Apparatus for handling liquids and a process for operating the device	356/624		356/524	Spolaczek; Reiner	<input checked="" type="checkbox"/>	US							
	US 6819437 B2	20041116	:9	Apparatus for handling liquids and a process for operating the device	356/624	250/577; 356/128	356/524	Spolaczek; Reiner	<input checked="" type="checkbox"/>	US							
	US 6819436 B2	20041116	:42	Image capturing apparatus and distance measuring method	356/614	356/3.1; 356/4.07	356/524	Ono; Shuji	<input checked="" type="checkbox"/>	US							
	US 6763140 B1	20040713	:19	Method and apparatus for focusing a micro-imaging system onto a tilted or	382/255	250/201.6; 356/624	356/524	Skoll; David F.	<input checked="" type="checkbox"/>	US							
	US 6633390 B2	20031014	:46	Focus measurement in projection exposure apparatus	356/620	250/201.2; 250/201.4;	356/524	Shioide; Yoshihiro et al.	<input checked="" type="checkbox"/>	US							
	US 6620390 B1	20030930	:20	Wafer alignment sensor using a phase-shifted microlens array	356/400	356/401; 356/485	356/524	Johnson; Kenneth C.	<input checked="" type="checkbox"/>	US							
	US 6538751 B2	20030325	:48	Image capturing apparatus and distance measuring method	356/614	356/3.1; 356/602	356/524	Ono; Shuji	<input checked="" type="checkbox"/>	US							

[Hits] [Details] [Print]

Ready